

What is claim :

1. A composite solid polymer electrolyte membrane (SPEM) comprising a porous polymer substrate interpenetrated with an ion-conducting material, wherein the SPEM is substantially thermally stable to temperatures of at least about 100°C.
2. The SPEM of claim 1, wherein the SPEM is stable from at least about 100°C to at least about 175°C.
3. The SPEM of claim 1, wherein the SPEM is stable from at least about 100°C to at least about 150°C.
4. The SPEM of claim 1, wherein the SPEM is stable from at least about 120°C to at least about 175°C.
5. The SPEM of claim 1 wherein
 - (i) the porous polymer substrate comprises a homopolymer or copolymer of a liquid crystalline polymer or a solvent soluble thermoset or thermoplastic aromatic polymer, and
 - (ii) the ion-conducting material comprises a homopolymer or copolymer of at least one of a sulfonated, phosphonated or carboxylated ion-conducting aromatic polymer or a perfluorinated ionomer.
6. A composite solid polymer electrolyte membrane (SPEM) comprising a porous polymer substrate interpenetrated with an ion-conducting material, wherein
 - (i) the porous polymer substrate comprises a homopolymer or copolymer of a liquid crystalline polymer or a solvent soluble thermoset or thermoplastic aromatic polymer, and
 - (ii) the ion-conducting material comprises a homopolymer or copolymer of at least one of a sulfonated, phosphonated or carboxylated ion-conducting aromatic polymer or a perfluorinated ionomer.

7. SPEM of claims 1 or 6, wherein the porous polymer substrate comprises a microinfrastructure substantially interpenetrated with the ion-conducting material.

8. The SPEM of claims 1 or 6, wherein the porous polymer substrate comprises an extruded or cast film.

9. The SPEM of claim 5, wherein the SPEM substantially stable to temperatures of at least about 100°C.

10. The SPEM of claims 5 or 6, wherein the liquid crystalline polymer substrate comprises a lyotropic liquid crystalline polymer.

11. The SPEM of claim 10, wherein the lyotropic liquid crystalline polymer substrate comprises at least one of a polybenzazole (PBZ) and polyaramid (PAR) polymer.

12. The SPEM of claim 11, wherein the polybenzazole polymer substrate comprises a homopolymer or copolymer of at least one of a polybenzoxazole (PBO), polybenzothiazole (PBT) and polybenzimidazole (PBI) polymer and the polyaramid polymer comprises a homopolymer or copolymer of a polypara-phenylene terephthalamide (PPTA) polymer.

13. The SPEM of claims 5 or 6, wherein the thermoset or thermoplastic aromatic polymer substrate comprises at least one of a polysulfone (PSU), polyimide (PI), polyphenylene oxide (PPO), polyphenylene sulfoxide (PPSO), polyphenylene sulfide (PPS), polyphenylene sulfide sulfone (PPS/SO₂), polyparaphenylene (PPP), polyphenylquinoxaline (PPQ), polyarylketone (PK) and polyetherketone (PEK) polymer.

14. The SPEM of claim 13, wherein the polysulfone polymer substrate comprises at least one of a polyethersulfone (PES), polyetherethersulfone (PEES), polyarylethersulfone (PAS), polyphenylsulfone (PPSU) and polyphenylenesulfone (PPSO₂) polymer; the polyimide (PI) polymer comprises a polyetherimide (PEI) polymer; the polyetherketone

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23. The SPEM of claim 20, wherein the sulfonated wholly-aromatic ion-conducting polymer comprises a sulfonated derivative of at least one of a polysulfone (PSU), polyphenylene oxide (PPO), polyphenylene sulfoxide (PPSO), polyphenylene sulfide (PPS), polyphenylene sulfide sulfone

(PPS/SO₂), polyphenylene (PPP), polyphenylquinaline (PPQ), polyarylsulfone (PK), polyetherketone (PEK), polybenzazole (PBZ) and polyaramid (PAR) polymer.

24. The SPEM of claim 23, wherein

(i) the polysulfone polymer comprises at least one of a polyethersulfone (PES), polyetherethersulfone (PEES), polyarylsulfone, polyarylethersulfone (PAS), polyphenylsulfone (PPSU) and polyphenylenesulfone (PPSO₂) polymer,

(ii) the polybenzazole (PBZ) polymer comprises a polybenzoxazole (PBO) polymer;

(iii) the polyetherketone (PEK) polymer comprises at least one of a polyetherketone (PEK), polyetheretherketone (PEEK), polyetherketone-ketone (PEKK), polyetheretherketone-ketone (PEEKK) and polyetherketoneetherketone-ketone (PEKEKK) polymer; and

(iv) the polyphenylene oxide (PPO) polymer comprises at least one of a 2,6-diphenyl PPO, 2,6-dimethyl PPO and 1,4-poly phenylene oxide polymer.

25. The SPEM of claims 5 or 6, wherein the perfluorinated ionomer comprises a homopolymer or copolymer of a perfluorovinyl ether sulfonic acid.

26. The SPEM of claim 25, wherein the perfluorovinyl ether sulfonic acid is carboxylic- (COOH), phosphonic- (PO(OH)₂) or sulfonic- (SO₃H) substituted.

27. The SPEM of claim 1, wherein the ion-conducting material comprises at least one of a polystyrene sulfonic acid (PSSA), poly(trifluorostyrene) sulfonic acid, polyvinyl phosphonic acid (PVPA), polyacrylic acid and polyvinyl sulfonic acid (PVSA) polymer.

28. The SPEM of claims 1 or 6, wherein the porous polymer substrate comprises a homopolymer or copolymer of at least one of a substituted or unsubstituted polybenzazole polymer, and wherein the ion-

conducting material comprises a sulfonated derivative of a homopolymer or copolymer of at least one of a polysulfone (PSU), polyphenylene sulfoxide (PPSO) and polyphenylene sulfide sulfone (PPS/SO₂) polymer.

29. The SPEM of claim 28, wherein the polysulfone polymer comprises at least one of a polyethersulfone (PES) and polyphenylsulfone (PPSU) polymer.

30. The SPEM of claims 1 or 6, wherein the SPEM has a specific resistance from about 0.02 to about 20 $\Omega \cdot \text{cm}^2$.

31. The SPEM of claims 1 or 6, wherein the SPEM has a specific resistance of less than about 0.2 $\Omega \cdot \text{cm}^2$.

32. The SPEM of claims 1 or 6, wherein the SPEM has a thickness from about 0.1 mil. to about 5.0 mil.

33. The SPEM of claim 32, wherein the thickness is about 1 mil.

34. A method of producing a composite solid polymer electrolyte membrane (SPEM) in accordance with claims 1 or 6, comprising the steps of preparing a mixture of a polymer substrate and an ion-conducting material in a common solvent and casting or extruding a composite membrane from the mixture.

35. A method of producing a composite solid polymer electrolyte membrane (SPEM) in accordance with claims 1 or 6, comprising the steps of preparing a mixture of the polymer substrate and the ion-conducting material and extruding or casting a composite film directly from the mixture.

36. A method of producing a composite solid polymer electrolyte membrane (SPEM) comprising the steps of performing a sulfonation reaction within the pores of a polymer substrate, wherein the SPEM is substantially thermally stable to temperatures of at least about 100°C.

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37. Method of producing a composite solid polymer electrolyte membrane (SPEM) in accordance with claims 1 or 6, comprising the steps of solubilizing the ion-conducting polymer and imbibing the porous polymer substrate with the ion-conducting polymer.

38. A method of producing a composite solid polymer electrolyte membrane (SPEM) in accordance with claims 1 or 6, comprising the steps of preparing the polymer substrate and subsequently impregnating the substrate with appropriate monomers which are then polymerized in-situ to form the SPEM.

39. A device comprising a composite solid polymer electrolyte membrane in accordance with claims 1 or 6.

40. The device of claim 39, wherein the device is a fuel cell.

41. The device of claim 40, wherein the fuel cell is a direct methanol fuel cell or a hydrogen fuel cell.

42. A method of decreasing methanol crossover rate in the fuel cell of claim 41 by using the SPEM of claim 1 in an electrochemical reaction in the fuel cell.

43. The device of claim 40, wherein the fuel cell is used to supply power to an electronic device.

44. The device of claim 39, wherein the device is a system for membrane-based water electrolysis or chloralkali electrolysis.

45. The device of claim 39, wherein the device is a dialysis, electrodialysis or electrolysis system.

46. The device of claim 39, wherein the device is a pervaporation or gas separation system.

